

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Masaaki IKEGAMI

Application No. Unassigned

Filed: August 29, 2003

For: METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE

Art Unit: Unassigned

Examiner: Unassigned

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.

In re Appln. of Masaaki IKEGAMI
Application No. Unassigned

TITLE AMENDMENTS:

Replace the title with:

METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE